## Search Notes



| Application/Control No. | Applicant(s)/Patent Under Reexamination |
|-------------------------|---|
| 10707644                | PARDON ET AL.                           |
| Examiner                | Art Unit                                |
| Lovel, Kimberly         | 2167                                    |

| SEARCHED |     |          |           |          |  |
|----------|-----|----------|-----------|----------|--|
| Class    |     | Subclass | Date      | Examiner |  |
| 707      | 100 |          | 1/20/2009 | KL       |  |
| 707      | 607 |          | 11/7/2010 | KL       |  |

| SEARCH NOTES  |           |          |  |  |
|---|-----------|----------|--|--|
| Search Notes  | Date      | Examiner |  |  |
| EAST - see attached   | 1/20/2009 | KL       |  |  |
| Updated East Search - see attached                                | 3/13/2010 | KL       |  |  |
| Consulted and concurred allowability with Kuen Lu (Primary, 2156) | 11/4/2010 | KL       |  |  |
| Updated East Search - see attached                                | 11/7/2010 | KL       |  |  |

| INTERFERENCE SEARCH |          |      |          |  |
|---------------------|----------|------|----------|--|
| Class               | Subclass | Date | Examiner |  |

U.S. Patent and Trademark Office Part of Paper No. : 20101104